

Form PTO-1449 U.S. Dept. of Commerce Patent & Trademark Office List of Documents Cited by Applicant (Use several sheets if necessary)	Atty. Docket: YOR920000571US2 Serial No. Not Yet Assigned Applicant: Richard A. HAIGHT et al. 10/698,884 Filing Date: HEREWITH 10/31/2003
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U.S. PATENT DOCUMENTS

Ex'r's In'l	Document Number	Date	Name	Class	Sub- class	Filing Date, if applicable
<input checked="" type="checkbox"/>	AA1	6,090,507	July 18, 2000	Grenon et al. ✓		
<input checked="" type="checkbox"/>	AA2	5,246,745	September 1, 1993	Baum et al. ✓		
<input checked="" type="checkbox"/>	AA3	4,615,904	October 7, 1986	Ehrlich et al. ✓		
<input checked="" type="checkbox"/>	AA4	4,608,117	August 26, 1986	Ehrlich et al. ✓		
<input checked="" type="checkbox"/>	AA5	4,340,617	July 20, 1982	Deutsch et al. ✓		
<input checked="" type="checkbox"/>	AA6	5,753,320	May 19, 1998	Mikoshiba et al. ✓		
<input checked="" type="checkbox"/>	AA7	5,308,651	May 3, 1994	Ohta et al. ✓		
<input checked="" type="checkbox"/>	AA8	5,130,172	July 14, 1992	Hicks et al. ✓		
<input checked="" type="checkbox"/>	AA9	5,060,595	October 29, 1991	Ziv et al. ✓		
<input checked="" type="checkbox"/>	AB1	6,261,850	July 17, 2001	Marsh ✓		
<input checked="" type="checkbox"/>	AB2	6,312,768	November 6, 2001	Rode et al. ✓		
<input checked="" type="checkbox"/>	AB3	5,407,710	April 18, 1995	Baum et al. ✓		
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<input checked="" type="checkbox"/>	AB8	6,319,566	November 20, 2001	Polanyi et al. ✓		

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<input checked="" type="checkbox"/>	AB9	R. Solanki et al., "Laser Photodeposition of Refractory Metals", App. Phys. Lett. 38(7) April 1, 1981, pp. 572-574.
<input checked="" type="checkbox"/>	AC1	D.K. Flynn et al., "Deposition of Refractory Metal Films by Rare-Gas Halide Laser Photodissociation of Metal Carbonyls", J. Appl. Phys. 59 (11), 1 June 1986, pp. 3914-3917.
<input checked="" type="checkbox"/>	AC2	S.A. Trushin et al., "Femtosecond Dynamics and Vibrational Coherence in Gas-Phase Ultraviolet Photodecomposition of CR(CO) ₆ ", J. Phys. Chem. A 1998, 102, pp. 4129-4137. <i>no month</i>
<input checked="" type="checkbox"/>	AC3	R. Alexandrescu, "Laser-Stimulated Processes in Metal Carbonyls for Metal-Based Film Synthesis", Applied surface Science 106 (1996) pp. 28-37. <i>no month</i>
<input checked="" type="checkbox"/>	AC4	H.H. Gilgen et al., "Direct Writing of Metal Conductors with Near -uv Light", Appl. Phys. B 42, 55-66 (1987), pp. 55-66. <i>no month</i>

Examiner: <i>[Signature]</i>	Date Considered: <i>10/1/04</i>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	